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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Appl. No. : 10/685,588**  
**Applicants : Chia-Lin Hsu et al.**  
**Filed : October 16, 2003**  
**Title : Method for Preventing Edge Peeling Defect**  
**TC/A.U. : 2829**  
**Examiner : EVERHART, CARIDAD**  
**Docket No. : 025796-00009**

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 6, 2005

**AMENDMENT**

Sir:

This paper is in response to the Official Action dated March 22, 2005. Applicants respectfully request that Examiner reconsiders the application according to the following remarks.

Please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.